


<b>Search Notes</b>  	<b>Application/Control No.</b>  10573347	<b>Applicant(s)/Patent Under Reexamination</b>  BABITSKY ET AL.
	<b>Examiner</b>  Michael C Wimer	<b>Art Unit</b>  2821

<b>SEARCHED</b>			
<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>
343	790-793, 895	6/4/2009	MCW

<b>SEARCH NOTES</b>		
<b>Search Notes</b>	<b>Date</b>	<b>Examiner</b>

<b>INTERFERENCE SEARCH</b>			
<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>

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